

Docket No.: 66097-013

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Kouichi SAITOU, et al.	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: August 27, 2003	:	Examiner: Unknown
	:	
For: PHOTOMASK FOR MANUFACTURING SEMICONDUCTOR DEVICE		

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Handwritten signature of Arthur J. Steiner in black ink.

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<p>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p>	<p>ATTY. DOCKET NO. 66097-013</p>	<p>SERIAL NO.</p>
	<p>APPLICANT Kouichi SAITOU, et al.</p>	
<p>(PTO-1449)</p>	<p>FILING DATE August 27, 2003</p>	<p>GROUP</p>

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 5-313348	11/26/1993	RICOH CO LTD RICOH RES INST OF GEN ELECTRON		(w/English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

[illegible]

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.